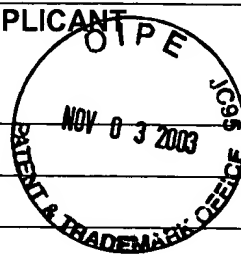


*U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. 5017/ISM/CORE /MCVD/SB	Serial No. 09/917,842
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Chin, et al.	Confirmation No.: 3573
(Use several sheets if necessary)		Filing Date July 27, 2001	Group 2125
Examiner Kosowski, A.			



U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
ASX	A1	6,342,277	01/29/02	Sherman	427	562	04/14/99
	A2	6,319,553	11/20/01	McInerney, et al.	427	250	02/28/00
	A3	6,206,967	03/27/01	Mak, et al.	118	666	06/14/00
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	A5	6,143,659	11/07/00	Leem	438	688	08/27/98
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Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation/Abstract	
							YES	NO
ASX	B1	2002 2060944	02/28/02	JP	C23C	16/30	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B2	01/29893	04/26/01	WO	H01L	21/768	<input type="checkbox"/>	<input type="checkbox"/>
	B3	01/29891	04/26/01	WO	H01L	21/768	<input type="checkbox"/>	<input type="checkbox"/>
	B4	01/27347	04/19/01	WO	C23C	16/44	<input type="checkbox"/>	<input type="checkbox"/>
	B5	01/27346	04/19/01	WO	C23C	16/44	<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
ASX	C1	Klaus, et al., "Atomically controlled growth of tungsten and tungsten nitride using sequential surface reactions," Applied Surface Science 162-163 (2000) 479-491
	C2	

Examiner *Alex Kosowski* Date Considered *11/18/03*

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.